

ABSTRACT OF THE DISCLOSURE

The slider according to the invention can prevent the phenomenon of sticking and reduce entrapping of foreign particles between the sliding surfaces. The method for making micro-
5 protrusions or micro-cavities on a surface of a substrate comprises the steps of: placing the substrate in a process chamber; supporting a mask member, having a micro shielding surface, independent of and in front of the substrate; and irradiating fast atomic beams onto the surface of the substrate
10 through the mask member.

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